



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

May 29, 2025

IGI Report Number **LG689562527**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNED RECTANGULAR MODIFIED BRILLIANT**

Measurements **8.09 X 5.70 X 3.77 MM**

GRADING RESULTS

Carat Weight **1.54 CARAT**

Color Grade **E**

Clarity Grade **INTERNAL FLAWLESS**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

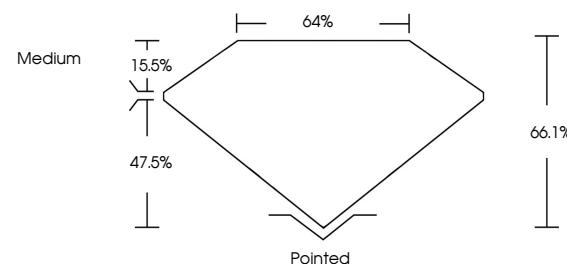
Inscription(s) **IGI LG689562527**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

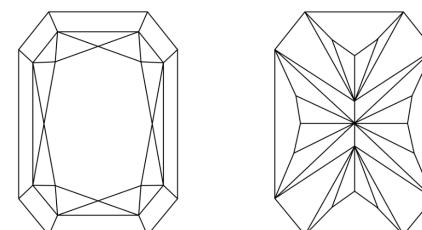
Type IIa

LG689562527
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

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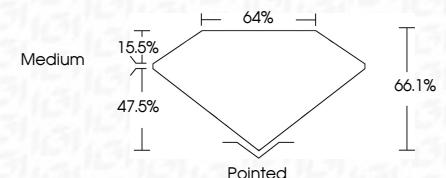
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Sample Image Used



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May 29, 2025	IGI Report No. LG689562527	CUT CORNED RECT. MODIFIED BRILLIANT	1.54 CARAT	E	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
			8.09 X 5.70 X 3.77 MM		Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
			Carat Weight						
			Color Grade						
			Clarity Grade						
			Depth						
			Table Grade						
			Culet						
			Polish						
			Symmetry						
			Fluorescence						
			Inscription(s)						

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa